

INFORMATION DISCLOSURE STATEMENT

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| Applicant | : Sherman |
| App. No | : 10/692,243 |
| Filed | : October 22, 2003 |
| For | : SEQUENTIAL CHEMICAL VAPOR DEPOSITION |
| Examiner | : Eric B. Fuller |
| Art Unit | : 1762 |

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing 1 reference to be considered by the Examiner. There are no foreign patent references and/or non-patent literature listed on the Information Disclosure Statement.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)

I hereby certify that each item of information contained in this Statement was first cited in a communication from a foreign Patent Office in a counterpart foreign application not more than 3 months prior to the filing of this Information Disclosure Statement.


Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c), however, the Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410.

Appl. No. : 10/692,243
Filed : October 22, 2003

Docket No. ASMMC.9CP1DV1D
Customer No. 20,995

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: Mar 3, 2008

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